

## WEST Search History

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DATE: Tuesday, August 10, 2004

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
	<i>DB=USPT; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L7	L6 and rinsing and drying	0
<input type="checkbox"/>	L6	L5 and (metallic contaminant)	13
<input type="checkbox"/>	L5	L4 and spraying	66
<input type="checkbox"/>	L4	L3 and (chelant or chelating or complexing or sequestering or sequester or sequesterant)	294
<input type="checkbox"/>	L3	cleaning and wafer and (carrier or cassette or container)	8879
<input type="checkbox"/>	L2	4133340.pn.	1
<input type="checkbox"/>	L1	5363867.pn.	1

END OF SEARCH HISTORY

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<u>Hide?</u>	<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L18	L17 and (metallic contamination)	7
<input type="checkbox"/>	L17	L16 and surfactant	121
<input type="checkbox"/>	L16	L15 and drying	147
<input type="checkbox"/>	L15	l12 and spraying	225
<input type="checkbox"/>	L14	L12 and (wafer cassette)	28
<input type="checkbox"/>	L13	L12 and (wafer containers)	8
<input type="checkbox"/>	L12	l1 and cleaning	1095
<input type="checkbox"/>	L11	l9 and cleaning	40
<input type="checkbox"/>	L10	l1 and (wafer cassette)	34
<input type="checkbox"/>	L9	l1 and (wafer carriers)	80
<input type="checkbox"/>	L8	l1 and (wafer containers)	9
<input type="checkbox"/>	L7	L6 and decontaminat\$	4
<input type="checkbox"/>	L6	l1 and 134/\$.ccls.	212
<input type="checkbox"/>	L5	l3 and (wafer containers)	5
<input type="checkbox"/>	L4	L3 and (metal remov\$)	10
<input type="checkbox"/>	L3	L2 and spraying	163
<input type="checkbox"/>	L2	L1 and carriers	991
<input type="checkbox"/>	L1	((complexing agent) or (chelating agent)) and semiconductor\$	3291

END OF SEARCH HISTORY